

# **NIRPS Backend Cryostat/Optomechanics**

**Leslie Saddlemyer**

**National Research Council - Canada  
Herzberg Institute of Astrophysics  
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# Summary

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- **SPIROU cryostat**
- **Design Concepts**
- **Assumptions**
- **Lessons learned**



# Basics

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- **Inspired by HARPS**
- **Extended to:**
  - NIR
  - 80K
- **Literature search**
  - Thermal measurement and control
  - Studied systems with microK level measurement and control
  - Find issues (eg Lakeshore metrology systems have documented dependence on electronics air temperature)
- **Selection of thermal control**
  - Methodology
  - Hardware



# Assumptions

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**Ensure that we simplify what has to be monitored/controlled**

- **No 'adjustments'**

- Hard bolted or bonded at all material interfaces
- Minimises chances of any physical changes
- NO mechanisms/changers/options

- **Simple**

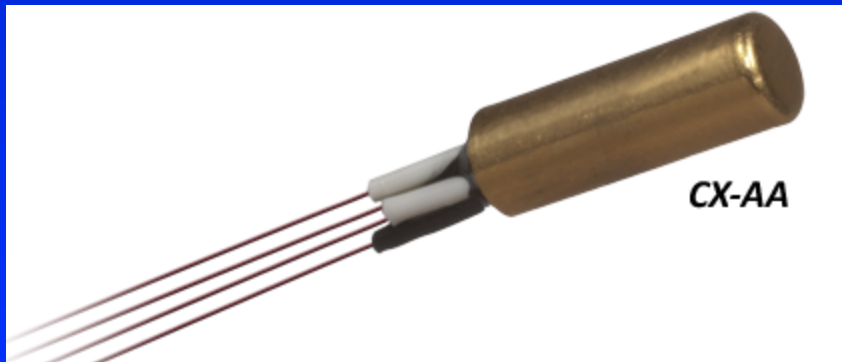
- Minimal components and joints
- Mechanical decoupling
  - Flexures
  - U-joints
- Thermally cohesive
  - All optical element mounts designed to remain at same relative heights
  - Aluminum is the default structure wrt bench/mounts
  - Invar etc utilized to compensate when necessary (eg parabola mount)
- Optics are flexure bonded/supported to minimise joint stiction

**→ Thermal changes dominate instabilities**

# Thermal Control Methodology

“With sufficient resolution in the control system, a well designed structure can be controlled to arbitrarily close to the measurement resolution”

- Analysis of the optics/design and mechanical structure
  - 1 to 2 mK stability level (24 hours)
- Resolution of critical components  $\ll 1$  mK ( $\sim 0.02$  mK)
  - CERNOX® 4-wire sensors
  - Micro-K® electronics for most critical components
- Precision of measurements  $\ll 1$  mK ( $\sim 0.1$  mK) on time-scales of months





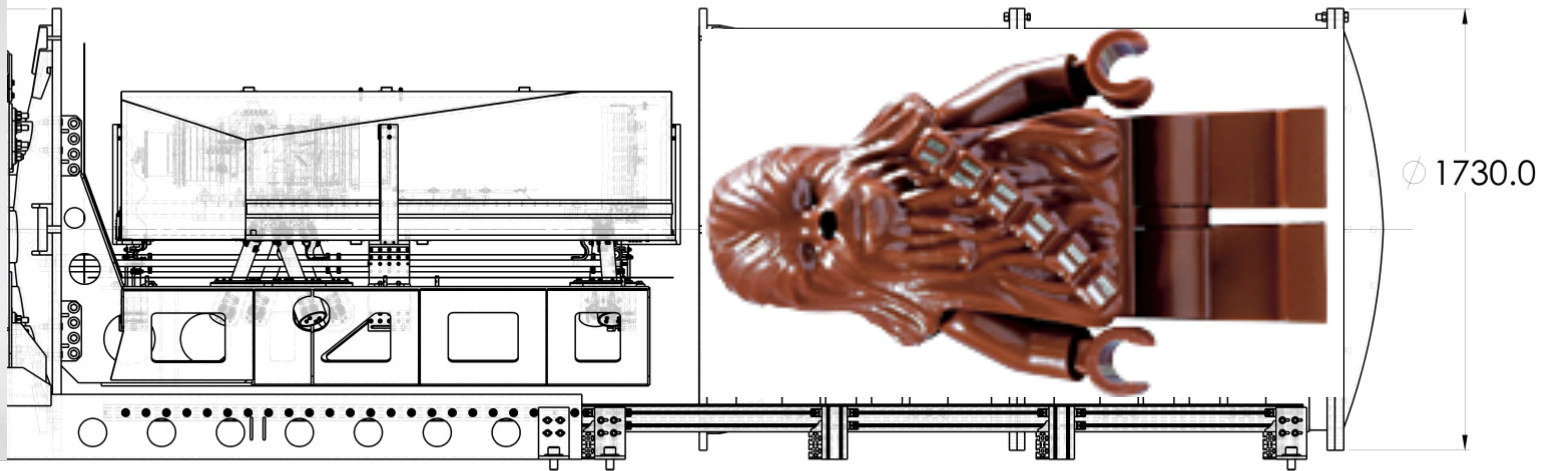
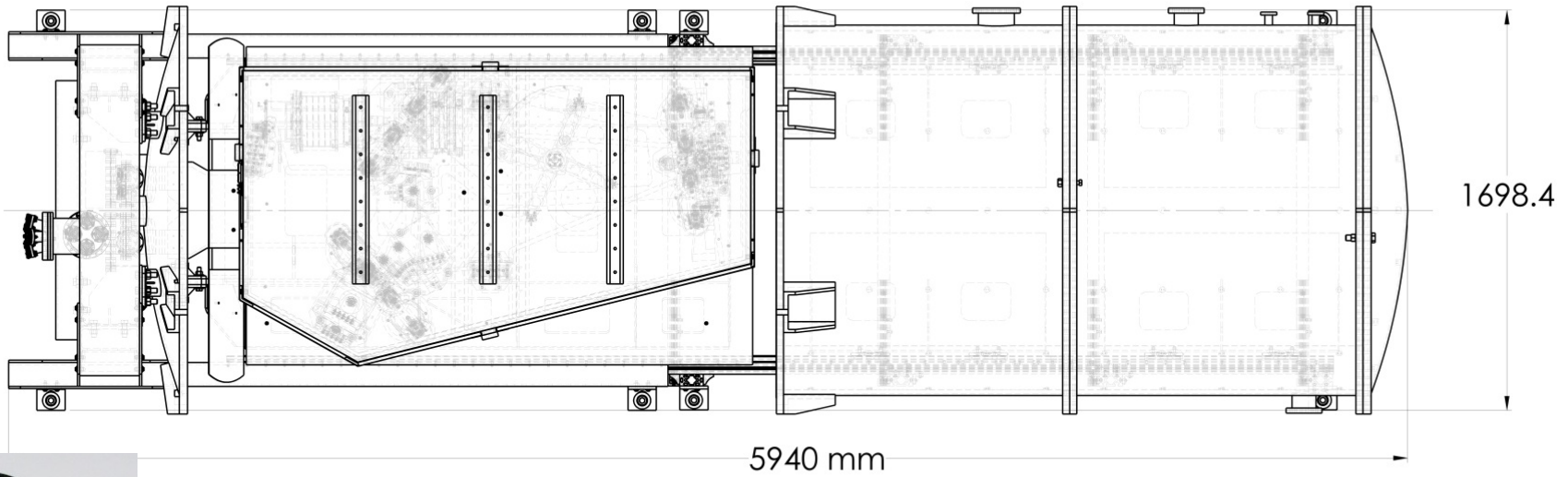
# Thermal Control Methodology

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## Layered approach

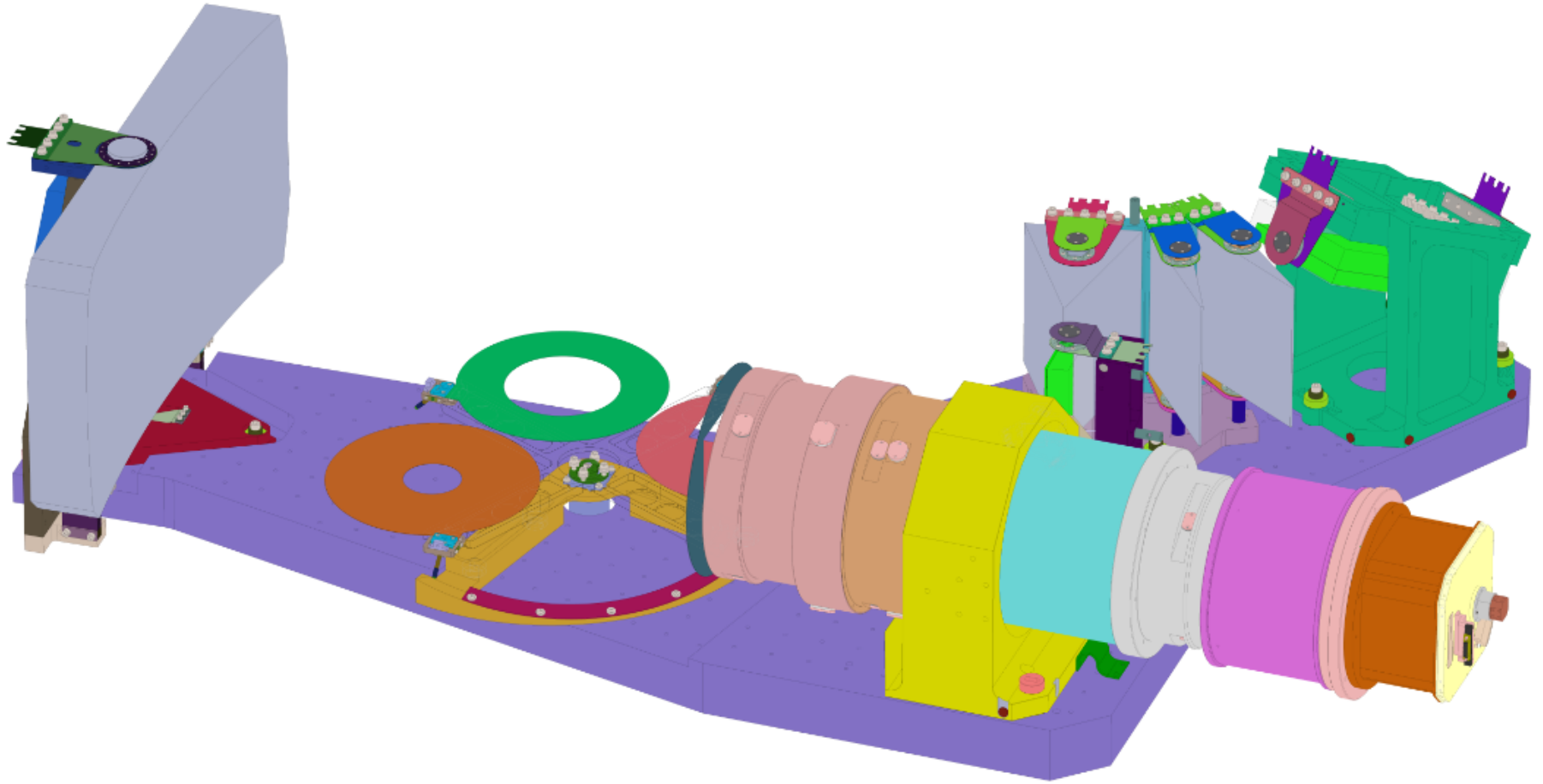
- Bench/shields
  - Supported on independent thermal isolation
  - Multiple radiation shielding
    - Optical bench/mounts: controlled to  $< 1$  mK
    - Passive radiation shield
    - Active radiation shield: controlled to  $< 10$  mK
    - Passive radiation shield
- Housing (cryostat)
  - Internal radiation shielding
  - External potential insulation (with optional heaters:  $\sim 0.1$  C)
- Lots of measurement points
  - 12 at  $< 1$  mK (Micro-K)
  - 24 at 1 mK (Lakeshore)



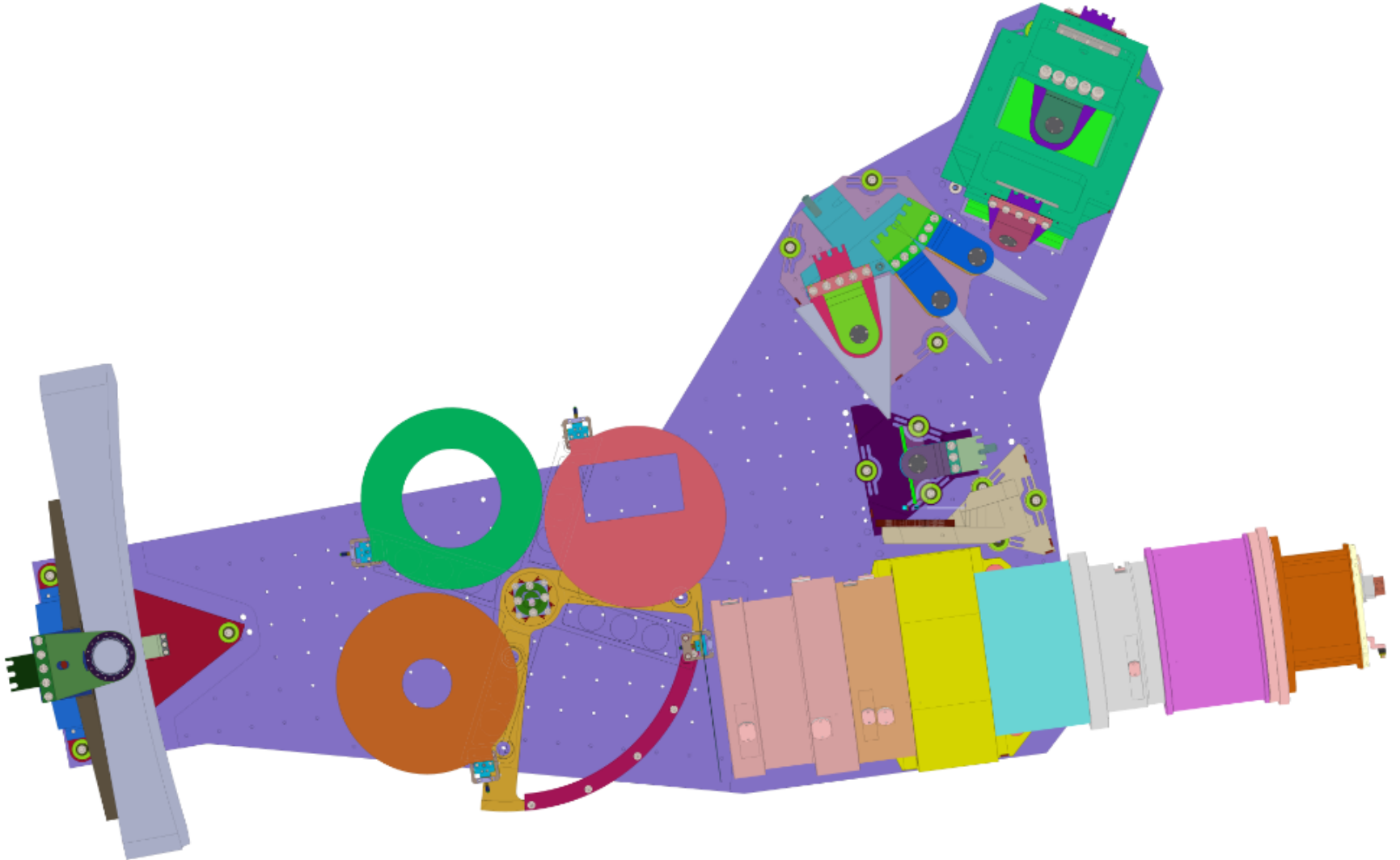


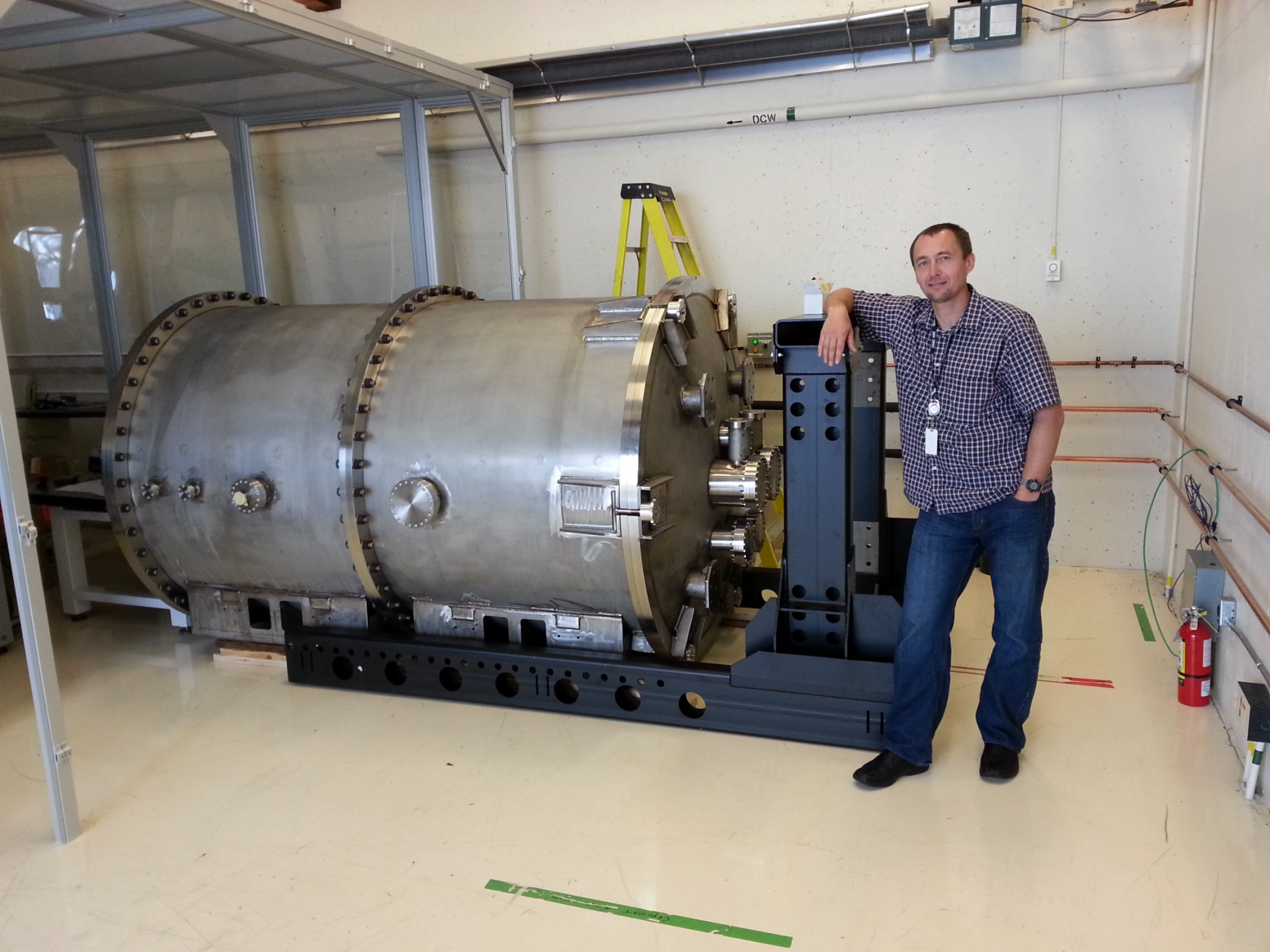
SPIROU CRYOSTAT, MAIN ASSY

DESIGNED BY	11/15/2011	DRAWN BY	5/18/2011
	RESHETOV		VLAD RESHETOV
MILLIMETERS	CHANGED	11/15/2011	SIZE SCALE SHEET
UNLESS SPECIFIED	RESHETOV		B 1:1 1
CATEGORY	PART NUMBER	VER	DOC TYPE OF
SPIROU -	SP-000-00778	03	DD 5









← DCW











# Lessons (???)

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- **Small, small, small**
  - I love the AO system
  - Keep the cryostat smaller
    - Less thermal mass to worry about
    - Easier to work on/transport etc
- **Simple**
  - Mounts
  - Control
  - operation
- **Choose wisely**
  - Quality components where it counts, such as the thermometry
  - Avoid temptation to try and be too complex (unless it turns out to be absolutely necessary)
  - Build early and test
  - Add incrementally as/if necessary